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June 23, 2009

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Title: POSITIVE PHOTORESIST COMPOSITION AND METHOD FOR
FORMING RESIST PATTERN
Letters Patent No. 7,449,276
Issued: November 11, 2008
Our Reference: SHIGA7.032APC

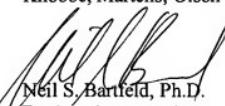
Dear Sir:

Enclosed for filing is a Certificate of Correction in connection with the above-identified patent.

As the errors cited in the Certificate of Correction were incurred through the fault of the Patent Office, no fee is believed to be required. However, please charge our Deposit Account No. 11-1410 for any fees that may be incurred with this request.

Respectfully submitted,

Knobbe, Martens, Olson & Bear, LLP



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Enclosures

7344304
062209

Orange County
949-760-0404

San Francisco
415-954-4114

Los Angeles
310-551-3450

Riverside
951-781-9231

Seattle
206-405-2000

Washington, DC
202-640-6400

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,449,276

Page 1 of 1

APPLICATION NO. : 10/554,380

ISSUE DATE : November 11, 2008

INVENTOR(S) : Hojo et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Page 2, Column 1, under "FOREIGN PATENT DOCUMENTS, third entry, change "2001-168478" to -2001-166478--.

Column 15, Line 26, in Claim 1, after "copolymer" insert --containing--.

Column 15, Line 40, in Claim 1, change "8.500" to --8,500--.

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062309

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DOCKET NO. SHIGA7.032APC